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TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Application Number	10/689,958
Filing Date	October 20, 2003
First Named Inventor	Cem Basceri
Art Unit	2812
Examiner Name	Unknown
Total Number of Pages in This Submission	1
Attorney Docket Number	MI22-2417

ENCLOSURES (Check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request Supplemental <input checked="" type="checkbox"/> Information Disclosure Statement	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation <input type="checkbox"/> Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____ <input type="checkbox"/> Landscape Table on CD	<input type="checkbox"/> After Allowance Communication to TC <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) (please Identify below): PTO Return Receipt Postcard Form PTO-1449 w/copies only of cited foreign patent and articles
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Firm Name	Wells St. John P.S.
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Printed name	Mark S. Matkin
Date	10/28/04
	Reg. No. 32,268

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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: **Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450**.

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EV 372470007



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No..... 10/689,958
Filing Date October 20, 2003
Inventor Cem Basceri
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Unknown
Attorney Docket No. MI22-2417
Customer No. 021567
Title: Methods of Forming Conductive Metal Silicides by Reaction of Metal with Silicon

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to 1276 OG 55, August 5, 2003, no copies of cited U.S. patents or U.S. patent application publications are included, as the date of filing of this patent application occurs after June 30, 2003. Copies of all other references are attached. No admission is made regarding whether all the listed references are prior art.

Citation of the referenced art is respectfully requested.

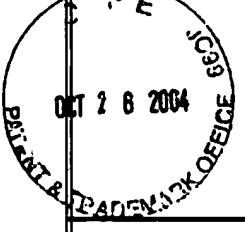
This Information Disclosure Statement is being filed before the mailing date of a first Office Action. There, no fee is believed to be required. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 10 -25-04

By:


Mark S. Matkin
Reg. No. 32,268

 Form PTO-1449 OCT 28 2004 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		LIST OF ART CITED BY APPLICANT <small>(Use several sheets if necessary)</small>			ATTY. DOCKET NO. MI22-2417		SERIAL NO. 10/689,958	
APPLICANT: Cem Basceri								
FILING DATE October 20, 2003					GROUP 2812			
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	3,349,474	12/1963	D. H. Rauscher				
	AB	5,904,517	05/1999	Gardner et al.	438	197		
	AC	5,998,264	12/1999	Wu	438	260		
	AD	6,180,465 B1	01/2001	Gardner et al.	438	291		
	AE	6,207,485 B1	03/2001	Gardner et al.	438	216		
	AF	6,548,854 B1	04/2003	Kizilyalli et al.	257	310		
	AG							
	AH	2003/0045060 A1	03/2003	Ahn et al.	438	287		
	AI	2003/0045078 A1	03/2003	Ahn et al.	438	585		
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
	AJ	EP 0 851 473 A2	01/1998	EPO			Yes	No
	AK						X	
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM	Chang et al., Silicon surface treatments in advanced MOS gate processing, Microelectronic Engineering, (2004), pages 130-135						
	AN	Lemberger et al., Electrical characterization and reliability aspects of zirconium silicate films obtained from novel MOCVD precursors, Microelectronic Engineering (2004), pages 315-320						
	AO	Lu et al., Effects of the TaN _x interface layer on doped tantalum oxide high-k films, VACUUM (2004), pages 1-9						
EXAMINER		DATE CONSIDERED						
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2417		SERIAL NO. 10/689,958		
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	AD								
	AE								
	AF								
	AG								
	AH								
	AI								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country		Class	Subclass	Translation	
								Yes	No
	AJ								
	AK								
	AL								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AM		Robertson et al., Atomic structure, band offsets, growth and defects at high-K oxide:Si interfaces, Microelectronic Engineering (2004) pages 112-120						
	AN		Singh et al., High and Low Dielectric Constant Materials, The Electrochemical Society <i>Interface</i> , Summer 1999, pages 26-30						
	AO								
EXAMINER		DATE CONSIDERED							
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									